

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Jean-Manuel Decams et al.

Application No.: 10/550,459

Filing Date: September 26, 2005

Title: METHOD FOR CVD DEPOSITION OF A SILVER FILM ON A SUBSTRATE

Group Art Unit:

Examiner:

Confirmation No.:

FIRST
INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is a FIRST Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- ☒ No additional fee for submission of an IDS is required.
- ☐ The fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- ☐ Charge _____ to Deposit Account No. 02-4800 for the fee due.
- ☐ A check in the amount of _____ is enclosed for the fee due.
- ☐ Charge _____ to credit card. Form PTO-2036 is attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BUCHANAN INGERSOLL PC

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By

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Date: February 6, 2006

Buchanan Ingersoll PC

ATTORNEYS

Including attorneys from Burns Doane Swecker & Mathis

(8/06)

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| OF A SILVER FILM ON A |) | |
| SUBSTRATE |) | |
| |) | |
| |) | |

FIRST INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The documents are being submitted within three (3) months of the filing or entry of the national stage of this application or before the first Office Action on the merits, whichever is later. Since these documents are being filed within the time period set forth in 37 C.F.R. § 1.97(b), no fee or statement is required.

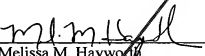
To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BUCHANAN INGERSOLL PC

Date February 6, 2006

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| NON-PATENT LITERATURE DOCUMENTS | |
|---------------------------------|---|
| Examiner Initials | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. |
| | International Search Report mailed September 3, 2004 |
| | Kuzmina et al., "Silver Pivalate as a New Volatile Precursor for Thin Film Deposition", Journal De Physique IV, Vol. 9, (1999), pp. 923-928. |
| | Edwards et al., "Aerosol-assisted Chemical Vapour Deposition (AACVD) of Silver Films from Triorganophosphine Adducts of Silver Carboxylates, Including the Structure of $[Ag(O_2CC_6F_7)(PPh_3)_2]$, Inorganica Chimica Acta, Vol. 328, (2002) pp. 134-146. |
| | Szlyk et al., "CVD of Ag ⁺ Complexes with Tertiary Phosphines and Perfluorinated Carboxylates – A New Class of Silver Precursors", Chemical Vapor Deposition, Vol. 7, No. 3, (2001), pp. 111-116. |
| | Paramonov et al., "MOCVD of Ag Thin Films", Journal De Physique IV: Proceedings, Vol. 11, No. Pr3, (2001) pp. 645-652. |
| | Szlyk et al., "Au ⁺ and Ag ⁺ Complexes with Tertiary Phosphines and Perfluorinated Carboxylates as Precursors for CVD of Gold and Silver", Chemical Vapor Deposition, Vol. 6, No. 3, (2000), pp. 105-108. |

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.